



# e-Vision 2

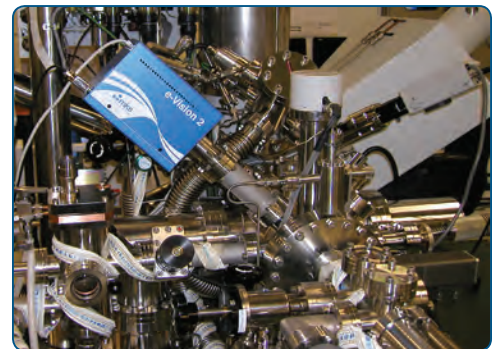
## STABILITY, ACCURACY AND SPEED A COST EFFECTIVE RGA FOR GENERAL PURPOSE VACUUM ANALYSIS

Residual Gas Analysis (RGA) is a routine workhorse tool for any vacuum engineer. The ability to quickly determine the individual gas partial pressures within a vacuum chamber provides a wealth of diagnostic information to help troubleshoot real and virtual leaks, identify components with abnormal out-gassing, identify contaminants and confirm when cryo-pumping and getter systems are close to needing regeneration. The e-Vision 2 RGA is one of a new range of products, from MKS, designed to meet all the traditional requirements for an RGA sensor but with data collection at speeds unachievable with previous generation technologies. The e-Vision 2 RGA is designed to provide maximum value for money. The e-Vision 2 is designed to collect data at millisecond speeds per data point even when measuring data over the full dynamic range of the RGA. This capability has been achieved without sacrificing any of the necessary robustness, reliability and support which have served to make MKS the world leader in RGA products over the widest range of applications — from semiconductor tools or particle accelerators to general industrial applications.

### Applications

The e-Vision 2 is suitable for a wide range of applications including:

- Leak detection of vacuum lines, welds and seals
- Vacuum diagnostics
- Pump down monitoring
- Chamber bakeout monitoring
- Leak checking of coolant lines within a vacuum chamber
- Chamber contaminant monitoring
- Monitor cryo-pump performance
- Monitor getter performance



*e-Vision 2 in use as a troubleshooting tool on vacuum-based surface analysis equipment*

**Mass Spectrometry Solutions**

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## Technology Leadership

MKS was the first company to offer an RGA compatible with modern Ethernet based web-enabled wide area network installations. The e-Vision 2 continues this development for the highest flexibility and connectivity through the use of industry standard communication hardware and software. The e-Vision 2 optimizes the roles required of a complex sensor by having two dedicated processors, one optimized, proprietary processor for data acquisition and one industry standard CE operating system processor for external communications through field proven TCP-IP technology.

The advantages of this design approach are fast, accurate data from a robust RGA sensor using industry standard, flexible communication protocols, all at the best possible value for your investment.

## Hardware Performance

### Sensors

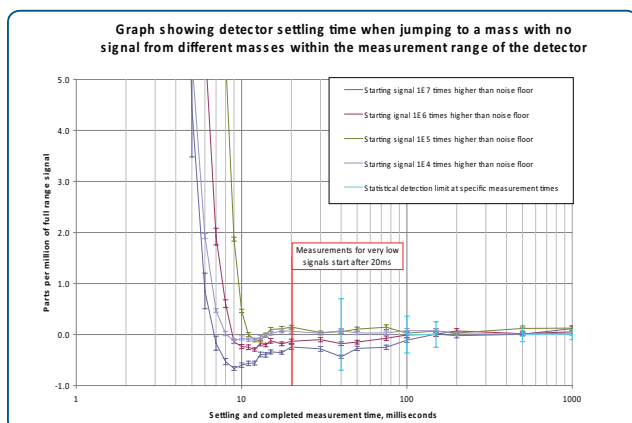
Field proven MKS quadrupole mass analyzers, with twin filaments as standard, ensure minimum downtime during critical diagnostic testing.

The RGA is available with an optional dual detector including a faraday detector and microchannel plate electron multiplier for detection to e-14 mbar.

### Electronics

Data acquisition occurs through all solid state, wide dynamic range, fast settling detector electronics. This technology prevents large peaks from causing false positive measurements on small peaks.

Temperature stabilized critical components mean that signal stability and baseline drift are improved, allowing the unit to be used without frequent recalibration if the vacuum chamber is stable but ambient air temperature fluctuates.



Signals close to the noise floor can still be reliably measured, even immediately after measuring very large signals

## Software Flexibility

### Built-in Web Application

A web interface using industry standard technology allows control of the e-Vision 2 as well as calibration, operation and data export through a non platform-specific web browser from anywhere on a network.

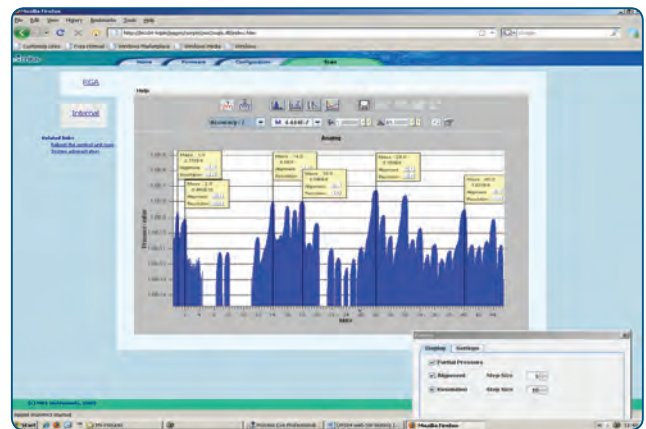
Using the ASCII protocol and TCP-IP communication, any third party software can send and receive commands and data from the e-Vision 2.

In addition to the standard, built-in web applications, software control is also available through an optional Windows application, offering the best possible fit to any customer requirement.

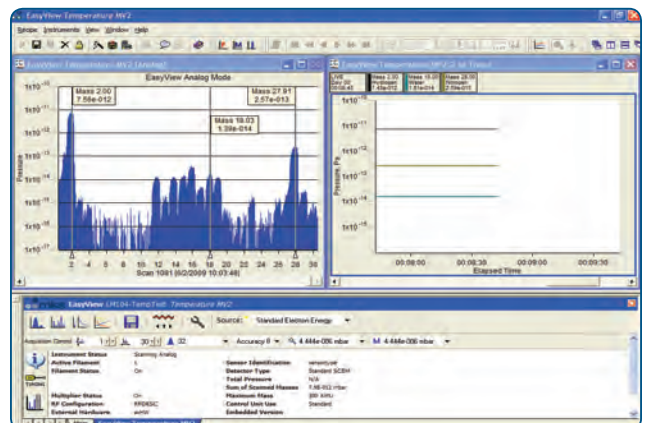
### EasyView

The field proven software provides basic RGA controls but with more functionality than the built-in web application

- Store RGA data and recall it back into the Recall viewer
- Annotate graphs with notes
- Run several RGAs from one software package



Built-in web application for e-Vision 2 control and data acquisition



EasyView software for more sophisticated data management and control of multiple RGAs



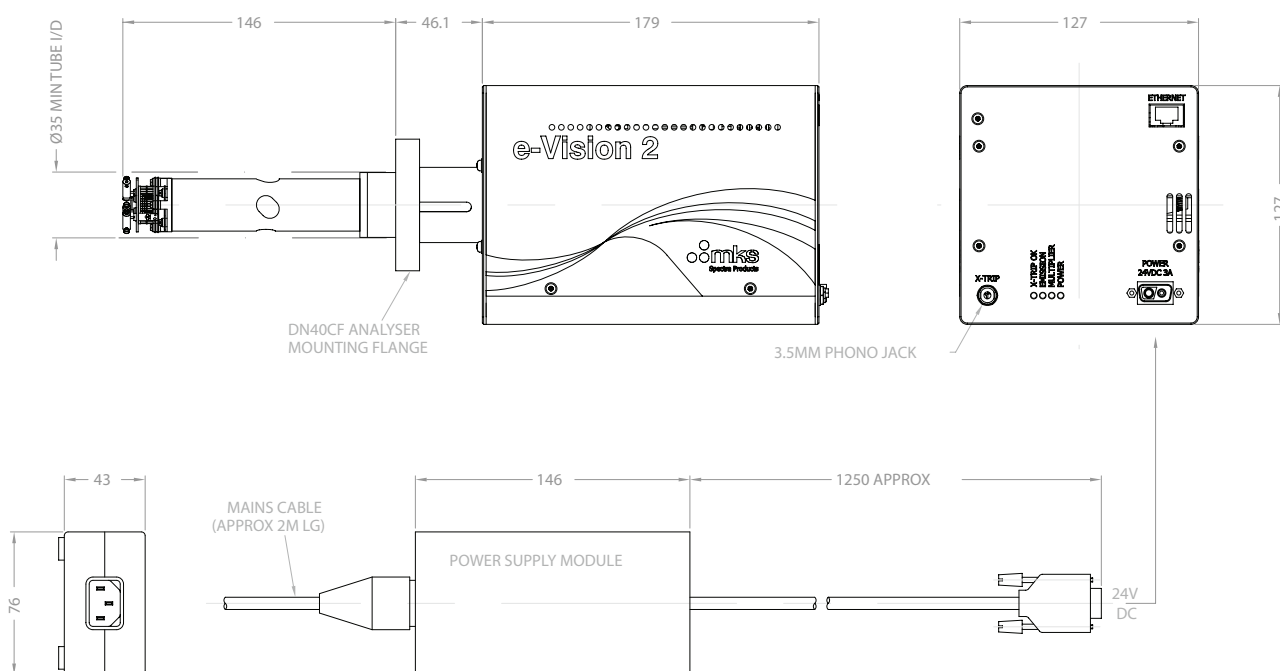
## Specifications

<b>e-Vision 2 Electronics</b>	
<b>Mounted weight on flange</b>	1.7kg
<b>Power</b>	24V DC, 2A external universal voltage supply (included)
<b>Maximum operating conditions</b>	10-40°C, 80% RH (non condensing)
<b>Communication</b>	10/100 Base-T Ethernet, static or automatically assigned IP addresses
<b>Data acquisition method</b>	Dedicated realtime acquisition processor
<b>Data collection methods</b>	Analog scanning, full mass range 8, 16 or 32 points/amu Barchart scanning Peak-jump collection of up to 15 peaks per scan
<b>Maximum data acquisition speed</b>	<3ms per point for analog scans
<b>Settling time from Full Range to Baseline Signal</b>	<20ms
<b>Control method</b>	CE operating system processor with web-server interface
<b>Command structure</b>	Documented ASCII command protocols
<b>Electron energy</b>	40 or 70eV fixed (set in web configuration)
<b>Emission current</b>	1 mA
<b>Filament protection</b>	Opto-isolated input for filament protect or control with auto detection of presence of the jack plug as failsafe
<b>Software</b>	Built-in web applications allowing RGA control and data acquisition without installed software using web browser on any PC Optional EasyView for Windows 2000, XP or Vista

<b>e-Vision 2 Analyzers</b>	
<b>Mass range</b>	100 or 200 amu
<b>Filter length</b>	4" (100mm)
<b>Detector</b>	Faraday or Dual Faraday Microchannel Plate Electron Multiplier
<b>Filaments</b>	Tungsten or Thoria Coated Iridium
<b>Maximum operating pressure</b>	1e-4 Torr (1.3e-4 mbar)
<b>Ion source sensitivity</b>	2e-4 A/mbar
<b>Minimum detectable partial pressure (3<math>\sigma</math> baseline noise at 300ms integration)</b>	2e-11 Torr (2.6e-11 mbar) Faraday 5e-14 Torr (6.7e-14 mbar) Multiplier
<b>Mass stability</b>	$\pm$ 0.1 amu over 8 hours at stable ambient
<b>Resolution</b>	Better than 10% valley for peaks of equal height across mass range
<b>Bakeout temperature</b>	250°C with electronics removed
<b>Operating temperature</b>	200°C Faraday only with electronics 10-40°C 150°C Multiplier with electronics 10-40°C and pressure <1e-8 mbar 90°C Multiplier with electronics 10-40°C and pressure <1e-5 mbar
<b>Compliance</b>	CE

# Ordering Information

Ordering Code: EVX-YZ0-00A (Example: EV2-120-000)	Code	Example Configuration
<b>e-Vision 2</b>	<b>EV</b>	<b>EV</b>
<b>Software Option (X)</b>		
Web Application Only	2	2
EasyView	E	
<b>Mass Range (Y)</b>		
100 amu	1	1
200 amu	2	
<b>Detector Type (Z)</b>		
Faraday Only	1	2
Multichannel Plate Dual	2	
<b>Reserved Digits 6, 7, and 8 (0-00)</b>		
TBD	0-00	0-00
<b>Filament Choice (A)</b>		
Tungsten Filaments	0	0
Thoria Coated Iridium	1	



## Dimensional Drawing —

Note: Unless otherwise specified, dimensions are nominal values in mm.



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